

| | Application No. | Applicant(s) |
|--|---|------------------------------------|
| Notice of Allowability | 10/518,501 | REY-MERMET ET AL. |
| | Examiner | Art Unit |
| | David Y. Chung | 2871 |
| The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. | | |
| 1. This communication is responsive to | | |
| 2. The allowed claim(s) is/are 23-51. | | |
| 3. Acknowledgment is made of a claim for foreign priority unally all b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: | be been received. be been received in Application No. | · |
| Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. | | ly complying with the requirements |
| 4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give | | |
| 5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. | | |
| (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached | | |
| 1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date | | |
| (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date | s Amendment / Comment or in the | e Office action of |
| ldentifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t | | |
| 6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. | | |
| Attachment(s) | E T Nietze settlet | I Detent Application |
| Notice of References Cited (PTO-892) Dotice of Draftperson's Patent Drawing Review (PTO-948) | 5. ☐ Notice of Informal 6. ☐ Interview Summa | • • |
| , , , | Paper No./Mail [| Date |
| Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date <u>20 December 2004</u> | 7. 🗌 Examiner's Amer | ndment/Comment |
| Examiner's Comment Regarding Requirement for Deposit of Biological Material | 8. 🛛 Examiner's State | ment of Reasons for Allowance |
| or biological iviaterial | 9. Other | |
| | (| |
| David Nelms | | |
| Supervisory Patent Examiner Technology Center 2800 | | |

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Allowable Subject Matter

The following is an examiner's statement of reasons for allowance: none of the

prior art taught or suggested the following method steps: depositing a contact bump

made of an electrically conductive material on each electrode in the region where the

electrodes are flush with the edges of the cell; structuring at least one wall on one of the

substrates, which defines, via its inner lateral face, the volume for retaining the sensitive

material, the wall extending in a set back position with respect to the edges of the cell.

Any comments considered necessary by applicant must be submitted no later

than the payment of the issue fee and, to avoid processing delays, should preferably

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to David Y. Chung whose telephone number is (571) 272-

2288. The examiner can normally be reached Monday thru Friday from 8:30 am to 5:00

pm. If successive attempts to contact the examiner are unsuccessful, the examiner's

supervisor David C. Nelms can be reached at (571) 272-1787.

Supervisory Patent Examiner

Technology Center 2800

David Y. Chung **GAU 2871** 09/30/06